



Attorney Docket SEL 163

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of)
Murakami et al.)
Serial No.: 09/516,082)
Filed: March 1, 2000)
For: Semiconductor Device Comprising)
A Thin Film Transistor Comprising)
A Semiconductor Thin Film And)
Method of Manufacturing The Same)
Art Unit: 2815)
Examiner: E. Lee)

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Shannon Wallace

Name of applicant, assignee, or Registered Rep.

Shannon Wallace

9/11/03

Signature

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AMENDMENT D

Sir:

In response to the Office Action of June 11, 2003, please amend the above-identified application as follows: